



Docket No.: 0756-7197

ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER

IRRADIATION APPARATUS AND METHOD OF

MANUFACTURING SEMICONDUCTOR

DEVICE

)  
) Group Art Unit: 1765  
) Examiner: R. Kunemund

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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*Terry L. Huse*

**REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson  
Reg. No. 38,285

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